

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI

Application No. 09/620,968

Filed: July 20, 2000

For: METHOD OF FORMING INSULATION  
FILMS CAPACITANCES, AND  
SEMICONDUCTOR DEVICES



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Group Art Unit: 2814

Examiner: Nathan W. Ha

Confirmation No. 4214

Date: March 7, 2005

AMENDMENT

Mail Stop **RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Further to the Notice of Appeal filed on November 5, 2004, please amend the above identified application as follows.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 6 of this paper.

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